



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Kazuya Kamon

Application No.: 10/630,775

Filed: July 31, 2003

For: **SIMULATOR FOR A CHEMICAL
MECHANICAL POLISHING**

MAIL STOP RCE

Group Art Unit: 2123

Examiner: ANDRE PIERRE LOUIS

Confirmation No.: 7888

AMENDMENT WITH RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action dated June 22, 2007, the period for response to which having been extended by three months to December 22, 2007, please amend the above-identified patent application as follows.

The Office was officially closed from December 22, 2007 to December 25, 2007. Therefore, this communication is timely filed within the statutory period for responding to the Office Action.